

10/579051

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s) : Terry L. Alford *et al.*
Application Serial Number : To be assigned
Date of Filing : May 9, 2006
Title : *FLEXIBLE ELECTRONICS USING ION IMPLANTATION
TO ADHERE POLYMER SUBSTRATE TO SINGLE
CRYSTAL SILICON SUBSTRATE*
Group Art Unit : To be assigned
Examiner : To be assigned
USPTO Customer No. : 26707
Attorney Docket No. : 112624.00062

**INFORMATION DISCLOSURE STATEMENT
PURSUANT TO 37 C.F.R. § 1.97**

Commissioner for Patents
U.S. Patent & Trademark Office
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Alexandria, VA 22313

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Terry L. Alford *et al.*
Information Disclosure Statement

10/3/9051

APR 29 2006 MAY 2006

No fee is believed due with this mailing. The Commissioner is hereby authorized to charge any cost that may be due to Deposit Account No. 17-0055.

Respectfully submitted,
QUARLES & BRADY STREICH LANG, LLP

May 9, 2006

By: _____



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INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)		Complete if Known	
		Application Number	To be assigned 2005/0051 10/579,051
		Filing Date	May 9, 2006
		First Named Inventor	Terry L. Alford
		Art Unit	To be assigned 2812
		Examiner Name	To be assigned S. Isaac
Sheet 2 of 2	Attorney Docket Number	112624.00062	

OTHER PRIOR ART—NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
/S.I./	A	Hochbauer et al., "Physical mechanisms behind the ion-cut in hydrogen implanted silicon", J. Appl. Phys., 92(5):2335-2342, 2002	
/S.I./	B	Hochbauer et al., "Investigation of the cut location in hydrogen implantation induced silicon surface layer exfoliation", J. Appl. Phys., 89(11):5980-5990, 2001	
/S.I./	C	Hochbauer et al., "Hydrogen blister in boron and hydrogen coimplanted n-type silicon", Appl. Phys. Lett., 75(25):3938-3940, 1999	

Examiner Signature	/Stanetta Isaac/ (03/30/2008)	Date Considered	03/30/2008
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.
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